

Electronic Acknowledgement Receipt

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Title of Invention:	Apparatus and method for vaporizing solid precursor for CVD or atomic layer deposition
First Named Inventor:	Lawrence C. Lei
Customer Number:	44257
Filer:	Keith M. Tackett/Tammi Thomas
Filer Authorized By:	Keith M. Tackett
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		005191C1Y1_ROA_EF.pdf	351079	yes	9

	Multipart Description		
	Doc Desc	Start	End
	Amendment - After Non-Final Rejection	1	5
	Applicant Arguments/Remarks Made in an Amendment	6	9
Warnings:			
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